



IFW

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.3109

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Jota FUKUHARA, et al. ) Group Art Unit: 2813  
)  
Application No.: 10/635,676 ) Examiner: Blum, David S.  
)  
Filed: August 7, 2003 )  
)  
For: SEMICONDUCTOR DEVICE AND )  
MANUFACTURING METHOD )  
THEREFOR )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

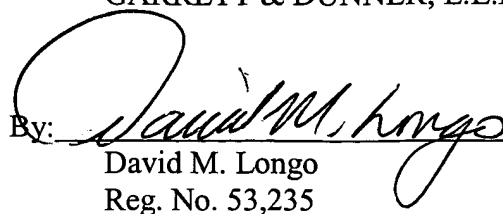
In the Restriction Requirement mailed February 2, 2005, with a period for response extending to March 2, 2005, the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 1-12) and Group II (claims 13-26). Applicants elect to prosecute Group I, claims 1-12, characterized by the Examiner as drawn to a method of making a semiconductor, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: February 28, 2005

By:   
David M. Longo  
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